

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/583,688	KIM ET AL.
	Examiner	Art Unit
	YEWEBDAR T. TADESSE	1792

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
118	667,308	9/10/2009	YTT
	302		
239	135		